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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Mamoru NAKASUJI et al.**

Group Art Unit: **2881**

Application Number: **09/891,611**

Examiner: **Jack I. Berman**

Filed: **June 27, 2001**

Confirmation No.: **8874**

For: **INSPECTION SYSTEM BY CHARGED PARTICLE BEAM AND
METHOD OF MANUFACTURING DEVICES USING THE
SYSTEM**

Attorney Docket Number: **010817**
Customer Number: **38834**

AMENDMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

June 16, 2006

Sir:

This paper is filed in response to the Office Action dated March 29, 2006.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 10 of this paper.